



252 AF
2823

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Wilk *et al.*

Docket: TI-24742

Serial No.: 09/176,422

Examiner: N. Berezny

Filed: 10/21/98

Art Unit: 2823

For: Low Temperature Method for Forming a Thin, Uniform Oxide

#10
3-7-01
C. Brown

NOTICE OF APPEAL FROM THE PRIMARY EXAMINER TO THE BOARD OF
PATENT APPEALS AND INTERFERENCES

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Tina Rendon
Tina Rendon

February 27, 2001

Assistant Commissioner for Patents
Washington, D. C. 20231

Examiner:

Applicant appeals to the Board of Appeals from the Primary Examiner's decision dated
December 6, 2000, which finally rejected Claims 1 - 25.

03/07/2001 AJOHNS01 00000003 200668 09176422
01 FC:119 Account No. **20-0668**. Please charge the required fee to the deposit account of Texas Instruments Incorporated,
310.00 CH Two additional copies of this notice are enclosed.

Respectfully submitted,

David Denker
Reg. No. 40,987

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